



503.39737X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. OTSUBO

Serial No.: 09/842,000

Filed: April 26, 2001

For: PLASMA PROCESSING APPARATUS AND PROCESSING
METHOD

Group: 1762

PRELIMINARY AMENDMENT

Commissioner of Patents
Washington, DC 20231

November 29, 2001

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

IN THE SPECIFICATION:

Please replace the original specification with the attached Substitute Specification.

IN THE ABSTRACT OF THE DISCLOSURE:

Please replace the original abstract with the following new abstract:

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